## <u>AMENDMENTS</u>

Please amend the above-identified application as follows:

## In the Claims

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In accordance with 37 C.F.R. § 1.121, please substitute the following clean copy text for the pending claims of the same number:

- (Four Times Amended) An organic light emitting device, comprising: 1. 1 an electrode; a current self-limiting structure comprising conducting regions dispersed in a non-conducting matrix; and an organic stack located between said electrode and said current 5 self-limiting structure. (Four Times Amended) A method for increasing the reliability of an
  - 10. organic light emitting device, comprising the steps of: forming an organic light emitting device including an organic stack; and incorporating a current self-limiting structure comprising conducting regions dispersed in a non-conducting matrix within said organic light emitting device.

## Please add the following new claims:

The device as defined in claim 1, wherein the current self-limiting structure 29. 1 is a ceramic material and the matrix is a photoresist material. 2

The device as defined in claim 1, wherein the current self-limiting structure 30. 1 is a ceramic material and the matrix is a polymer.

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- The device as defined in claim 1, wherein the current self-limiting structure 31. 1 is a polymer composite containing inorganic conducting particles. 2
- The device as defined in claim 1, wherein the current self-limiting structure 32. 1 is a conductive polymer. 2
- The method as defined in claim 10, wherein the current self-limiting 33. 1 structure is formed using a ceramic material and the matrix is formed using a photoresist 2 material. 3
- The method as defined in claim 10, wherein the current self-limiting 34. 1 structure is formed using a ceramic material and the matrix is formed using a polymer. 2
- The method as defined in claim 10, wherein the current self-limiting 35. 1 structure is formed using a polymer composite containing inorganic conducting particles. 2
- The method as defined in claim 10, wherein the current self-limiting 36. 1 structure is formed using a conductive polymer. 2